



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Allan et al.
Serial No: 09/675721
Filed: 9/29/2000
For: DEEP UV LASER INTERNALLY
INDUCED DENSIFICATION IN SILICA
GLASS

Examiner: Hoffman, John
Group Art Unit: 1731

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.56, 1.97 – 1.98**

Commissioner of Patents
Alexandria, VA 22313-1450


Dear Sir:

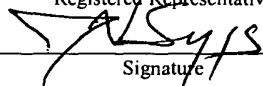
The Examiner's attention is hereby directed to the following reference(s) listed on the attached Form PTO-1449 for consideration in connection with the examination of the above-identified patent application. One copy of the reference(s) is enclosed.

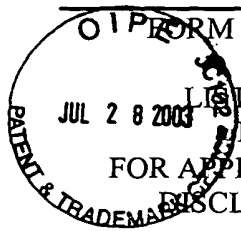
This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the enclosed documents constitute "prior art." If it should be determined that any of the submitted documents do not constitute "prior art" under United States law, applicant(s) reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicant(s) further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the enclosed references, should one or more of the references be applied against the claims of the present application.

Respectfully submitted,


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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner of Patents, Alexandria, VA 22313-1450 on	
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Date of Deposit	
James V. Suggs	
Name of applicant, assignee, or Registered Representative	
	
Signature	
7-24-03	
Date of Signature	



FORM PTO-1449 (MODIFIED) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS INFORMATION DISCLOSURE STATEMENT	ATTORNEY DOCKET NO. SP00-080	SERIAL NO. 09/675721
	APPLICANT: Allan et al.	
	FILING DATE 9/29/2000	GROUP: 1731

REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
	AA	5634955	6/3/1997	Araujo et al.			

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
	BA	10288799	10/27/1998	Japan (abstract & machine translation)			
	BB	11167036	6/22/1999	Japan (abstract only)			

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)		
CA	Svalgaard et al., "Direct UV Writing of Buried Singlemode Channel Waveguides in Ge-doped Silica Films", Electronics Letter, 18 th August 1994, Vol. 30, No. 17, pp. 1401-1403	
CB	Svalgaard, M. "Direct Writing of Planar Waveguide Power Splitters and Directional Couplers Using a Focused Ultraviolet Laser Beam", Electronics Letters, 25 th September 1997, Vol. 33, No. 22, 2 pages total.	

EXAMINER: _____ DATE CONSIDERED: _____

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.